

PATENT Customer No. 22,852 Attorney Docket No. 04329.2306

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re	Application of:)
Yoshio Ozawa et al.) Group Art Unit: 2823
Application No.: 09/559,757) Examiner: Pham, Thanh V.
Filed: April 27, 2000)		<i>)</i>)
For:	METHOD OF MANUFACTURING A SEMICONDUCTOR DEVICE USING AN OXIDATION PROCESS	Confirmation No.: 2923)
P.O. I	nissioner for Patents Box 1450 ndria, VA 22313-1450	
Sir:		

PETITION FOR EXTENSION OF TIME

Appellants petition for a one month extension of time to submit the attached. A fee of \$120.00 is enclosed.

Please grant any extensions of time required to enter this response and charge any additional required fees to our deposit account 06-0916.

Respectfully submitted,

02/07/2006 SZEWDIE1 00000041 09559757

Dated: February 6, 2006

02 FC:1251

120.00 OP

FINNEGAN, HENDERSON, FARABOW, GARRETT & DUNNER, L.L.P.

By:_

David L. Soltz

Reg. No. 34,731